



Contribution ID: 878

Type: **not specified**

4MP5-18 Assessment of $\text{Bi}_2\text{Sr}_2\text{CaCu}_2\text{O}_8$ Thin Films Grown by MOCVD for Power Electronics Applications

Thursday 21 September 2017 10:30 (1 minute)

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Session Classification: Poster : 4MP5 - Cuprate Thin Films 2/2